

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**priority** Application Serial No. .... 10/364,054  
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Inventor..... Luan C. Tran  
Assignee..... Micron Technology, Inc.  
**priority** Group Art Unit ..... 2812  
**priority** Examiner ..... Kennedy, Jennifer J.  
Attorney's Docket No. .... MI22-2357  
Title: Methods of Forming Semiconductor Constructions

**PRELIMINARY AMENDMENT**

To: Mail Stop Patent Application  
Commissioner for Patents  
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**AMENDMENTS**